

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/602,223	<b>Applicant(s)/Patent under Reexamination</b> YAMAGAMI, KENJI
	<b>Examiner</b> Tammy T. Nguyen	<b>Art Unit</b> 2144

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner